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- Silver as a Removable Coating for Scanning Electron Microscopy
- Carbon Coating Techniques and Applications
- Plasma Etching and Ashing Techniques and Applications
- A summary of the Critical Point Drying Method
- · Freeze Drying Principles
- · Cryo-SEM the Advantages



The new brochure as well as the EMS printed catalog and CD-ROM eBook can be ordered on line.

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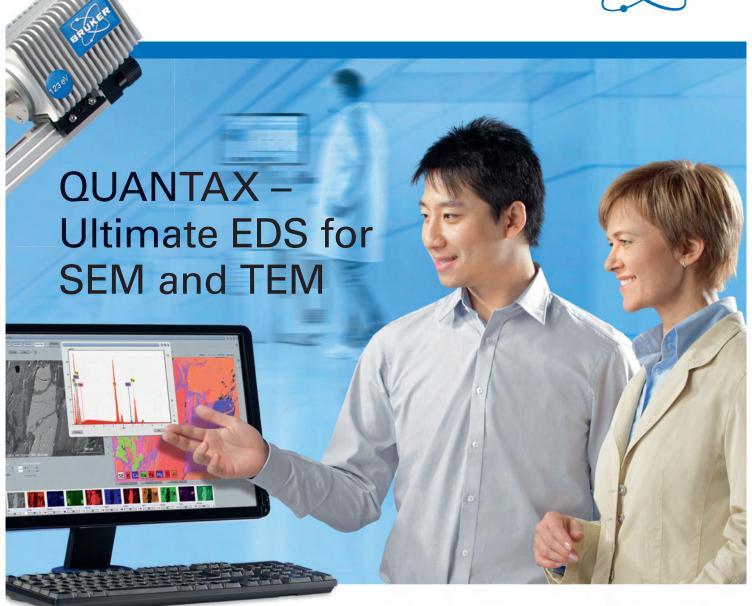


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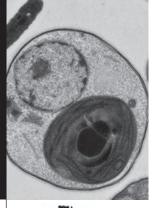


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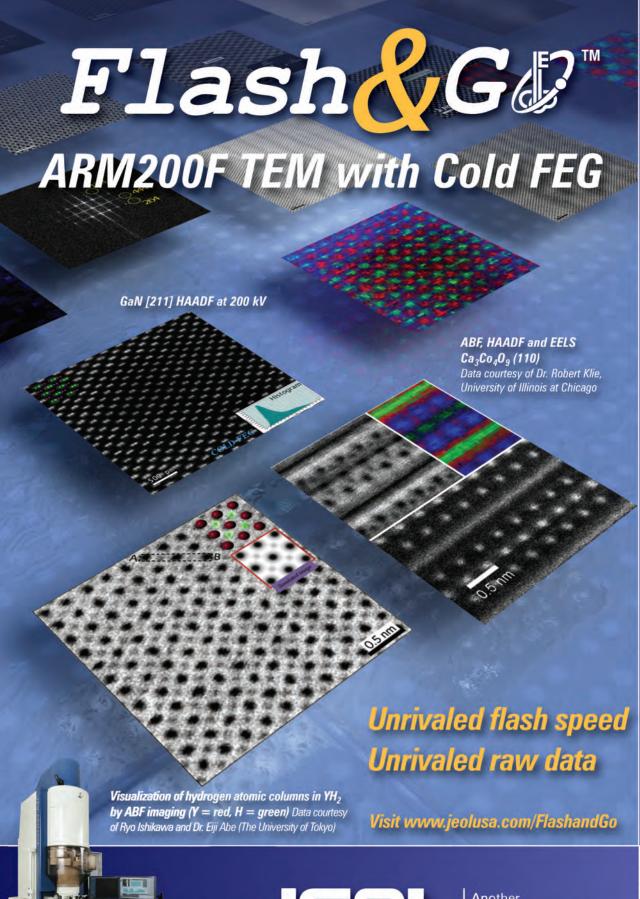
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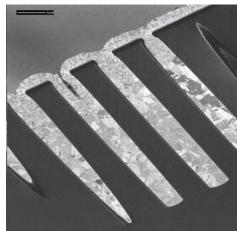


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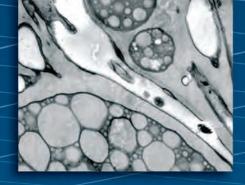
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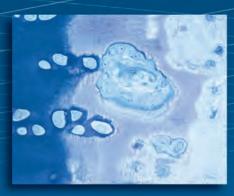
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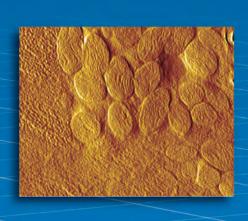
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The SPI Supplies Vacu Prep II™ is a fast, clean, high vacuum, bench top evaporator with simple automated operation for evaporation or sputtering. It utilizes solid state electronics to control the pumpdown, evaporation and venting sequences. A turbo molecular pump is the heart of the system, but it still fits on the bench top.

Safe, reliable, and easy to maintain, the Vacu Prep II can be used for routine carbon coating or the evaporation of various metals and materials.

With quick pump down times, the system can quickly achieve an ultimate base vacuum in the 10⁻⁷ torr range. The Vacu Prep II features a large baseplate that accommodates more feed-throughs, more fixturing, and more applications.

Short Pump Down Cycles

The compound turbo molecular pump operates at a speed of 65 liters/second to achieve excellent base vacuum levels and gas load handling.

Powerful Control System

A touch screen interface provides full control for the following modes: service, manual, and semi-automatic. Standard software makes it easy to support and avoid costly customization fees. The safety interlock will mitigate damage to the operator and equipment.

Typical Applications

- Electron Microscopy Sample Preparation
- High-Vacuum Carbon Coating for TEM and X-Ray Analysis
- Resistance Evaporation of Metallic Compounds
- Carbon Support Films
- Carbon Platinum Replicas
- Rotary Shadowing
- Aperature Cleaning
- Asbestos Analysis
- Failure Analysis

The Vacu Prep II has a size of 31"w (78.7 cm) x 28"d (71.1 cm) x 30"h (76.2 cm) and weighs 250 lb (113.4 kg)

Large chamber up to 12" diameter (30.5 cm) x 18"h (45.7 cm) provides ample space for evaporation and sputtering applications.

It is available in 110V (12200-AB) and 220V models.



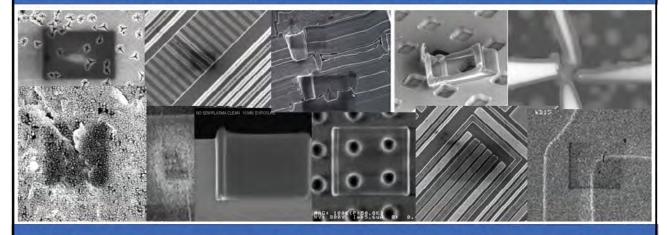
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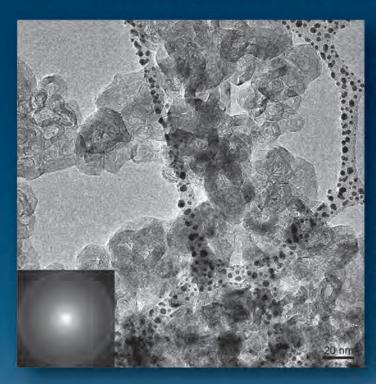
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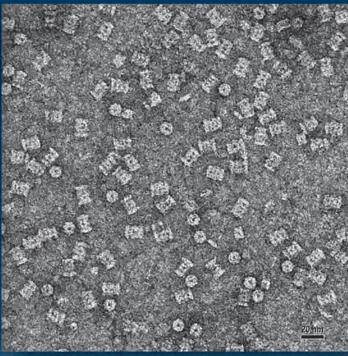
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K2

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Left image: Graphite fringes demonstrating resolution to Nyquist limit; imaged on Gatan K2Base[™] camera at 14.5kx nominal TEM magnification and 200 kV.

Right image: 20S proteasome negatively stained by uranyl formate showing 1k x 1k region of interest; imaged on Gatan K2Base[®] camera at 9.6kx nominal TEM magnification and 200 kV. Sample courtesy Dr. Yifan Cheng, University of California, San Francisco.





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